L Number	Hits	Search Text	DB	Time stamp
-	211	73/170.11	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:43
-	9	("5423209" "3699811" "5466067" "5406839" "5396524" "5412983" "5117687" "4833917" "4388691").pn.	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:58
-	28	73/170.11 and probe	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:47
-	0	73/170.11 and "MEMS probe"	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:48
-	0	73/170.11 and "MEMS"	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:48
-	36	73/170.11 and (omni-direction$4 adj sensor detector)	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:52
-	9	(73/170.11 and probe) and (73/170.11 and (omni-direction$4 adj sensor detector))	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:49
-	6	73/170.11 and (pressure near4 (probe vane))	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:54
-	0	(73/170.11 and probe) and micromachine	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:55
-	1	73/170.11 and micromachine$3	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:55
-	0	(73/170.11 and probe) and micromachine$3	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:58
-	1	73/170.11 and micromachin$3	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:58
-	354	73/180	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:59
-	0	73/180 and micromachin$3	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:59
-	3467	micromachined	USPAT; US-PGPUB; EPO; JPO	2002/08/30 15:59
-	795	micromachined and (pressure near4 (sens$4 detect$4 apparatus device))	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:00
-	159	(micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:01
-	82	((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:01
-	64	(((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer) and array	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:01
-	18	((((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer) and array) and (sensor adj array)	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:05

-		1	(((((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer) and array) and (sensor adj array)) and (bossed near4 diaphragm)	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:05
-		12	(((((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer) and array) and (sensor adj array)) and diaphragm	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:05
-		1	((((micromachined and (pressure near4 (sens$4 detect$4 apparatus device))) and (probe vane)) and transducer) and (bossed near4 diaphragm)	USPAT; US-PGPUB; EPO; JPO	2002/08/30 16:05